

TRANSMITTAL

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Title of Invention	HDPCVD PROCESS AND METHOD FOR IMPROVING UNIFORMITY OF FILM THICKNESS							
Application Number :								
Date :								
First Named Applicant:	Mr. Chien-Hung Lu							
Confirmation Number:								
Attorney Docket Number:	13622-US-PA							
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<table border="1"><tr><td>Submitted By:</td><td>Elec. Sign.</td><td>Sign. Capacity</td></tr><tr><td>Dr. Belinda Lee Registered Number: 46863</td><td>/Belinda Lee/</td><td>Agent</td></tr></table>			Submitted By:	Elec. Sign.	Sign. Capacity	Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent
Submitted By:	Elec. Sign.	Sign. Capacity						
Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent						

Documents being submitted:	Files
us-assignment	13622-usassn.xml us-assignment.xsl us-assignment.dtd 13622assignment01.tif 13622assignment02.tif
us-request	13622-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	13622-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
application-body	13622usf.xml application-body.dtd Image1.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl wipo.ent
application-body-pdf-wrap	13622usf-pdf-wrap.xml
abstract-pdf	13622usf-abst.pdf
claims-pdf	13622usf-clms.pdf
description-pdf	13622usf-desc.pdf
drawings-pdf	13622usf-draw.pdf
us-declaration	13622declaration01.tif

Comments

Please be kindly advised that the indicated fee of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fee in connection with this application to Deposit Account No. 50-2620(Order No. 13622-US-PA). Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: Belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw